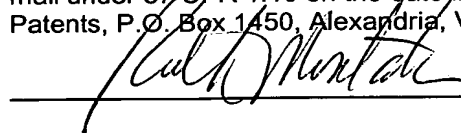


EXPRESS MAIL No.: EL 962 857 875 US

Deposited: September 23, 2005

I hereby certify that this correspondence is being deposited with the United States Postal Service Express mail under 37 CFR 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-450



/ Ruth Montalvo Date: 09/23/05

Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: GK-OEH-191/500814.20093

U.S. Application No.: 10/521,088

International Application No.: PCT/DE2003/002359

International Filing Date: JULY 10, 2003

10 JULY 2003

Priority Date Claimed: JULY 12, 2002

12 JULY 2002

Title of Invention: PULSE LASER ARRANGEMENT AND METHOD FOR SETTING PULSE LENGTH FOR LASER PULSES

Applicant(s) for (DO/EO/US): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Mail Stop PCT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-450

**SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT**

S I R:

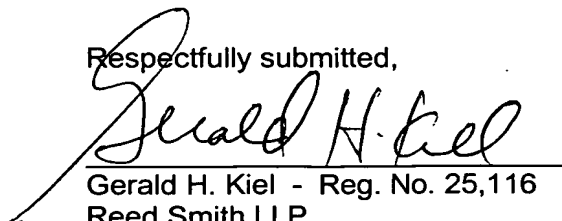
Supplemental to the information Disclosure Statement filed on January 12, 2005, applicants submits a copy of article AX previously omitted and a Supplemental PTO-1449.

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AX R. Iffländer, Solid state Lasers for Materials Processing, Springer Series in Optical Sciences, Springer Verlag, Berlin (2001), pages 28-32

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,



Gerald H. Kiel - Reg. No. 25,116
Reed Smith LLP
599 Lexington Avenue
New York, NY 10022-7650

GHK:ram
09/23/05
Tel. (212) 521-5400

Enclosures:
Suppl PTO-1449 and article;

SUPPLEMENTA'
LIST OF PRIOR ART CITED BY APPLICANT
 (Filed on September 23, , 2005)

Docket No. GK-OEH-191/500814.20093

Applicant(s): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Application No. 10/521,088 (Int'l Appln No. PCT/DE2003/002359 10JUL03) Group:

Filed: Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	4,725,787	02/16/1998	Chandra			
	AB	4,896,119	01/23/1990	Williamson, et al.			
	AC	5,867,324	02/02/1999	Kmetec, et al.			
	AD	5,907,570	05/25/1999	Nighan, et al.			
	AE	6,122,097	09/19/2000	Weston, et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation	
							YES	NO
	AL	1 308 384	02/28/1973	Great Britain				
	AM	0 609 978	08/10/1994	European				
	AN	WO 96/16484	05/30/1996	WIPO				
	AO	199 27 918	12/21/2000	Germany			Abstract only	
	AP	199 58 566	06/07/2001	Germany			Abstract only	
	AQ	2 357 369	06/20/2001	Great Britain				
	AR	100 43 269	04/04/2002	Germany			Abstract only	
	AS	100 63 976	07/04/2002	Germany			Abstract only	
	AT							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AX	R. Iffländer, Solid state Lasers for Materials Processing, Springer Series in Optical Sciences, Springer Verlag, Berlin (2001) pages 28-32
AY	
AZ	

Examiner:

Date:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

NOTE: Strikethrough documents were submitted on January 12, 2005